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PATENT & TRADEMARK OFFICE

Dkt. 2271/65887-Z

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Shunichi SATO et al.

Serial No. : 10/677,065 Group Art Unit: 2822

Date Filed : October 1, 2003 Examiner: Mary A. Wilczewski

For: VERTICAL-CAVITY, SURFACE-EMISSION TYPE LASER DIODE AND FABRICATION PROCESS THEREOF

Conf. No.: 8107 Class-Subclass: 438-047000

Issue Fee Due Date: January 9, 2006

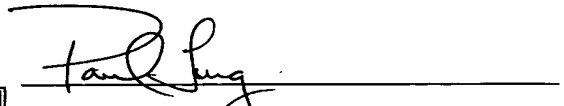
Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICANTS' COMMENTS ON
EXAMINER'S STATEMENT OF REASONS FOR ALLOWANCE

Sir:

Applicants appreciate the Examiner's Statement of the Reasons for Allowance attached to the Notice of Allowability dated October 7, 2005 and submit that the allowed claims recite subject matter which further supports patentability for reasons in addition to those identified in the Reasons for Allowance.

Respectfully submitted,



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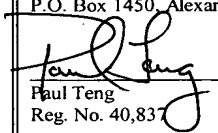
I hereby certify that this correspondence is being deposited this date with the U.S. Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



January 6, 2006
Date

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